



Serial No. 09/899,784

Image

AF 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Patent Application of

Inventor(s): Dong-Su Kim

Group Art Unit: 2823

Serial No.: 09/899,784

Examiner: Toledo, Fernando L

Filing Date: July 5, 2001

For: Method of Fabricating Silica Microstructures

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Commissioner for Patents
P.O. Box 1450
Alexandria, Va 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the Final Office Action dated November 19, 2003, please amend
the above-identified application as follows.